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(REV. 05/03)	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>	ATTY. DOCKET NO.	APPLICATION NO.
		BDL-487XX	10/549444
		APPLICANT: Eric Sion et al.	
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U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	PUBLICATION/ ISSUE DATE	NAME	CLASS	SUBCLASS	FILING DATE
	US 6,001,419	12/14/1999	Leluan et al. [Delperier]			
	US					
	US					
	US					
	US					

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
	WO 96/15285	5/23/1996	WIPO			X

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)

	Glasier, G.F. et al: "Formation of pyrolytic carbon during the pyrolysis of ethane at high conversions," CARBON, Elsevier Science Publishing, New York, NY, vol. 39, no. 1, pages 15-23 (January 2001).
	Becker, A., et al: "Chemistry and kinetics of chemical vapor deposition of pyrocarbon—II pyrocarbon deposition from ethylene, acetylene and 1,3-butadiene in the low temperature regime," CARBON, Elsevier Science Publishing, New York, NY, vol. 36, no. 3, pages 177-199 (1998).
	Delhaes, P.: "Chemical vapor deposition and infiltration processes of carbon materials," CARBON, Elsevier Science Publishing, New York, NY, vol. 40, no. 5, pages 641-657 (April 2002).

EXAMINER	/David Turocy/	DATE CONSIDERED	03/10/2009
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*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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REFERENCES FURNISHED BY INTERNATIONAL BUREAU (PCT/FR2004/001009)

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /D.T./